

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79562

Shinji TANAKA Appln. No.: 10/766,005

Group Art Unit: 2115

Confirmation No.: 2005

Examiner: Thomas C. LEE

Filed: January 29, 2004

For:

MEDIUM CONTAINING PRINTER MAINTENANCE GUIDE PROGRAM FOR AUTOMATIC

DISPLAY ON A COMPUTER IN RESPONSE TO DETECTING A CHANGE IN THE PRINTER

STATUS

SUBSTITUTE INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant previously filed an Information Disclosure Statement on August 25, 2005 referencing the incorrect publication date of the cited Japanese reference. Therefore, Applicant respectfully submits the attached substitute PTO/SB/08A & B (modified) form along with the correct publication date for the listed reference which the Examiner may deem material to patentability of the claims of the above-identified application. A copy of the listed reference was previously submitted on August 25, 2005.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

-Iyndman

ation No. 39,234

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: September 22, 2005

| | | | | MODIFIED F10/38/08 A & B (00-03) |
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| Substitute for Form 1449 A & B/PTO | | Complete if Known | | |
| | | Application Number | 10/766,005 | |
| SUBSTITUT | E INFORMAT | TION DISCLOSERE | Confirmation Number | 2005 |
| STAT | EMENT BY A | APPLICANT | Filing Date | January 29, 2004 |
| 0 | | First Named Inventor | Shinji TANAKA | |
| (use as many sheets as necessary) SEP 2 2 2005 | | | Art Unit | 2115 |
| \\\\ 3 | | Examiner Name | Thomas C. LEE | |
| Sheet | 1 | of Kh | Attorney Docket Number | Q79562 |
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| U.S. PATENT DOCUMENTS | | | | | | |
|-----------------------|--------------|-----------------|-----------------------------------|------------------|---|--|
| Examiner Initials* | Cite No.1 | Document Number | | Publication Date | | |
| | | Number | Kind Code ² (if known) | MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
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| Examiner Cite | Foreign Patent Document | | | Publication Date | Name of Patentee or | T | |
| Initials* | Initials* No.1 Co | Country Code ³ | Number ⁴ | Kind Code ⁵ (if known) | MM-DD-YYYY | Applicant of Cited Document | Translation ⁶ |
| | | JP | 5-324236 | A | 12-07-1993 | Richoh Co. Ltd. | W/English Abstract |
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| NON PATENT LITERATURE DOCUMENTS | | | | |
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| Examiner Initials* | Cite No.1 | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published. | Translation | |
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.